

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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## Title of Invention

CHEMICAL MECHANICAL POLISHING PROCESS

Application Number :

Confirmation Number:

First Named Applicant: Chia-Lin Hsu

Attorney Docket Number: NAUP0633USA

Art Unit:

Examiner:

Search string: ( 6573173 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6573173	2003-06-03	Farkas, ET AL.			

## Signature

Examiner Name	Date